

**INFORMATION DISCLOSURE CITATION**  
*(Use several sheets if necessary)*

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**Docket Number (Optional)**

**Application Number**

150

09/763,254

**Applicant(s)**

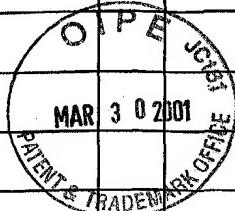
SCHMOLL, K., ET AL

**Filing Date**

02/20/2001

**Group Art Unit**

## **U.S. PATENT DOCUMENTS**



## **FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
PC	8-274381	10/18/96	JP				✓
PC	7-183586	07/21/95	JP				✓

**OTHER DOCUMENTS**    *(Including Author, Title, Date, Pertinent Pages, Etc.)*


**EXAMINER**

Pedro J. Cuevas

**DATE CONSIDERED**

12/2/01

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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1970 SPRING 3-2 EDITION

20 FEB 2001

## **U.S. PATENT DOCUMENTS**

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REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>BR</i>	0 479 328 A	04/08/92	EP				✓

**OTHER DOCUMENTS**    *(Including Author, Title, Date, Pertinent Pages, Etc.)*

<i>RC</i>	PATENT ABSTRACT OF JAPAN 07-183586 A, JULY 21, 1995.
<i>RC</i>	PATENT ABSTRACT OF JAPAN 08-274381 A, OCTOBER 18, 1996

**EXAMINED**

Pedro J. Cuevas

#### **DATE CONSIDERED**

12/2/04

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